E UNITED STATES PATENT AND TRADEMARK OFFIC

In re the Application of

Akira SATO

Filed: February 22, 2000

Application No.: 09/424,500

Docket No.:

Examiner:

Group Art Unit: 2825

104788

G. Lee, Jr.

For:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING

DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE

## REQUEST FOR RECONSIDERATION

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

In reply to the Office Action dated August 28, 2001, the period for reply being extended by the attached Petition for Extension of Time, reconsideration of the aboveidentified application is respectfully requested.

Claims 1-30 are pending. Reconsideration in view of the following remarks is respectfully requested.

## I. THE SPECIFICATION SATISFIES ALL FORMALITIES

The Office Action objects to the specification for not disclosing the items #52 and #84, which are depicted in the drawings. This objection is respectfully traversed.

Applicant respectfully submits that item 52 of Figures 1, 6, 7 and 8 are disclosed in page 9, lines 13-15. Item 52 coupled with an arrow is used to show the rotation space of a front cam of the present invention.